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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
DOHLE ET AL

Serial No. **10/732,777**

Filing Date: **DECEMBER 10, 2003**

Confirmation No. **6984**

For: **IMPROVED CONTACT STRUCTURE
FOR A SEMICONDUCTOR COMPONENT**

) Atty Docket No.:
) **78323CIP1**
) **(P1261G US CIP)**

) Art Unit: **2815**

) Examiner:
) **EUGENE LEE**

AMENDMENT

Mail Stop Amendment
Commissioner For Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated March 22, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

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